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## Detection of Pinholes in Ultrathin Films by Magnetic Coupling

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### Abstract

When two magnetic films are separated by a nonmagnetic film, pinholes in the nonmagnetic film can allow direct contact and, thereby, direct magnetic exchange coupling between the two magnetic films. We have studied this coupling by having one of the magnetic films pinned and leaving the other free to switch at low field. The pinning is accomplished with test structures based on exchange bias and synthetic antiferromagnetic layers. Since the pinning strength increases sharply at low temperatures but orange-peel coupling does not, low-temperature (77 K) measurements appear to identify whether an observed coupling arises primarily from magnetic coupling through pinholes or primarily from orange-peel roughness. Our measurements appear to indicate that the observed coupling arises primarily from magnetic coupling through pinholes for Cu films less than 2.1 nm thick and for Al<sub>2</sub>O<sub>3</sub> films less than 0.6 nm thick but primarily from roughness-induced (orange-peel) magnetostatic coupling for larger thicknesses.

### Introduction

Pinholes are widely believed to play a key role in limiting the performance of both giant magnetoresistance (GMR) spin valves and magnetic tunnel junctions (MTJs).<sup>1</sup> It is generally believed that as the spacer layer, Cu in the case of spin valves and Al<sub>2</sub>O<sub>3</sub> in the case of MTJs, is made thinner the value of the magnetoresistance (MR) increases until pinholes occur. Pinholes couple the two magnetic layers ferromagnetically, making it difficult to achieve antiparallel alignment, and thereby limiting the MR.

Pinholes are not easy to observe. There is some evidence from transmission electron microscopy (TEM) for the existence of pinholes, but in systems such as Co/Cu/Co the low electron-scattering contrast between elements of similar atomic number makes conclusive identification of pinholes difficult.<sup>1</sup> Another problem is that the thickness of the Cu layer is typically much smaller ( $\approx$  2 nm) than the depth of the TEM sample in the beam direction ( $\approx$  20 nm). If the diameter of a pinhole in the Cu film is similar to the thickness of the Cu film, it would be only  $\approx$  10 % of the sample depth thus exacerbating the contrast problem. In systems such as Al<sub>2</sub>O<sub>3</sub>/Co, there is some evidence that electrochemical deposition of Cu clusters can identify pinholes, although the applied potential may also create pinholes.<sup>1</sup>

Two groups have recently reported the use of magnetic hysteresis loops to study coupling between magnetic films of different coercivity separated by an insulating film.<sup>2</sup> The method appears to have much promise, and the present work is an extension of this concept.

The present work has two aims. One is to develop an improved method for observing the onset of pinholes as the spacer layer is made thinner. The other is to develop an improved method for distinguishing the regime of spacer-layer thickness in which pinhole coupling dominates from the one in which orange-peel coupling dominates.

## Experimental

The NiO substrates used in this work were polycrystalline films  $\approx$ 50 nm thick, deposited on 4" Si wafers by reactive magnetron sputtering at the University of California at San Diego. At the National Institute of Standards and Technology (NIST), the wafers were cleaved into  $\approx$ 1 cm<sup>2</sup> squares, cleaned ultrasonically in a detergent solution, rinsed in distilled water, blown dry, and installed in the deposition chamber. After bakeout, the deposition chamber has a base pressure of  $3 \times 10^{-8}$  Pa ( $2 \times 10^{-10}$  Torr), of which 90% is H<sub>2</sub>. The metal films were deposited at room temperature by dc-magnetron sputtering in 0.3 Pa (2 mTorr) Ar at a typical rate of  $\approx$ 0.05 nm/s. Oxide films are deposited by reactive sputtering, adding 0.01 Pa ( $10^{-4}$  Torr) O<sub>2</sub> to the Ar.

Magnetoresistance (MR) measurements were made at NIST with a 4-point probe in a direct current mode. The values of the coupling reported have an estimated uncertainty of  $\pm$  5 % due to the slight skew in the hysteresis loop of the free Co layer. The calibration of the Hall probe used for measurement of the applied field during MR measurements has an uncertainty of  $\pm$  2 %. The measurements at 77 K were performed with the sample immersed in liquid nitrogen. Additional experimental details may be found in Ref. 3.

## Results and Discussion

Structures of the type illustrated in Fig. 1 were used to investigate the magnetic coupling between two ferromagnetic layers. The concept behind the structure in Fig. 1 is to have two Co films separated by a non-magnetic spacer layer. The upper Co film is magnetically pinned by the synthetic antiferromagnet Co/Ru/Co and the natural antiferromagnet Ir<sub>20</sub>Mn<sub>80</sub>. The Co film below the non-magnetic spacer layer is free switch at low field whenever the non-magnetic spacer layer is thick enough to prevent magnetic coupling.

The lower parts of the structure constitute a GMR spin valve. GMR measurements are used to observe the hysteresis loop of the free Co layer. The synthetic antiferromagnet Co/Ru/Co and the natural antiferromagnet NiO substrate serve to pin the Co layer that is under the Cu. The Cu layer thickness in the spin valve is chosen to be 4 nm to ensure that the contribution to the coupling is insignificant from the Co layer below the Cu.

The coupling is observed as a shift from zero field in the center of the GMR hysteresis loop of the "free" Co. Figure 2 presents the coupling data for Al<sub>2</sub>O<sub>3</sub> as the non-magnetic spacer layer. With no spacer layer, the two Co films form a single layer 5 nm thick and the hysteresis loop center is shifted  $\approx$ 30 mT (300 Oe) from zero field. At 77 K this shift increases to  $\approx$ 60 mT (600 Oe) as the synthetic antiferromagnet Co/Ru/Co becomes stronger.

10 nm IrMn
2.5 nm Co
0.5 nm Ru
2.5 nm Co
Non-magnetic spacer layer
Free 2.5 nm Co layer
4 nm Cu
2.5 nm Co
0.5 nm Ru
2.5 nm Co
NiO substrate

Figure 1. An illustration of the type of test structure used in this study.

In Fig. 2 a spacer layer of 0.6 nm  $\text{Al}_2\text{O}_3$  is sufficient to suppress any significant temperature dependence in the coupling field. Apparently, this is the thickness at which magnetic pinholes cease to be significant. The coupling that is observed for 0.6 nm or more of  $\text{Al}_2\text{O}_3$  is probably magnetostatic and comes from the orange-peel effect.<sup>4</sup> Only a very slight increase in orange-peel coupling would be expected since the magnetization of Co increases by less than 1 % from 295 K to 77 K.

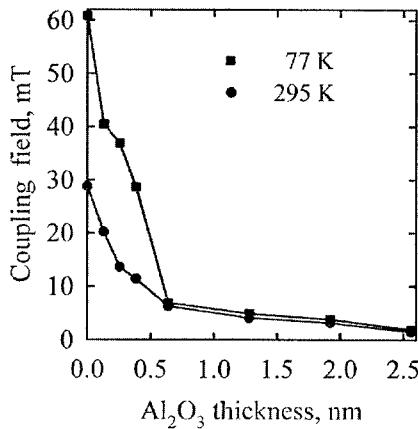


Figure 2. The coupling field observed in the GMR hysteresis loop of the free Co layer when the non-magnetic spacer layer is  $\text{Al}_2\text{O}_3$ , as a function of the spacer layer thickness.

It is significant that the magnetic pinholes appear to close up at an  $\text{Al}_2\text{O}_3$  thickness of 0.6 nm. In studies of magnetic tunnel junctions, it is generally found that this is the practical limit on how thin the  $\text{Al}_2\text{O}_3$  barrier can be made. Thinner  $\text{Al}_2\text{O}_3$  layers yield drastic reductions in tunneling MR. The results of Fig. 2 suggest that, in this thickness regime, magnetic pinholes would make it difficult to achieve the antiparallel magnetic state. Moreover, if as seems likely, the magnetic pinholes represent direct Co-Co contacts, these pinholes may be expected to act as current short circuits as well.

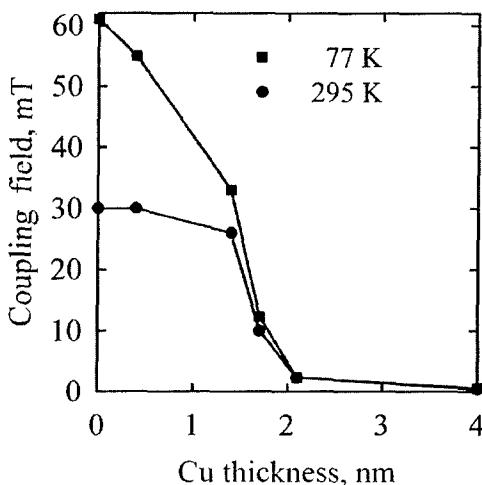


Figure 3. The coupling field observed in the GMR hysteresis loop of the free Co layer when the non-magnetic spacer layer is Cu, as a function of the spacer layer thickness.

Figure 3 presents the coupling results for Cu as the non-magnetic spacer layer. It may be noted that this choice of spacer layer turns the structure into a dual spin valve. As a result, there will be a contribution to the GMR from the top half of the dual spin valve. However, this effect does not detract from the validity of the measured coupling. The bottom Cu film is fixed at a thickness of 4 nm to make any contribution to the coupling from that side negligible. Only the upper Cu layer thickness is varied, and its thickness alone is responsible for the observed coupling.

The temperature dependence observed in Fig. 3 suggests that the magnetic pinholes dominate the coupling for Cu thicknesses from 0 nm to  $\approx 1.5$  nm and become insignificant when the Cu is thicker than  $\approx 2$  nm. Not surprisingly, this thickness corresponds well with what is generally used in GMR spin valves. It is commonly observed in GMR spin valves that below about 2 nm the coupling rises steeply.<sup>6</sup>

## Conclusions

The temperature dependence of the magnetic coupling is found to be a useful approach to separating the effects of magnetic pinholes in non-magnetic spacer layers from the effects of magnetostatic coupling, such as the orange-peel effect. Test structures based on GMR spin valves are convenient for investigations of such phenomena. We find that for Cu films of  $\approx 2$  nm or more and for Al<sub>2</sub>O<sub>3</sub> films of  $\approx 0.6$  nm or more magnetic pinholes do not make a significant contribution to the coupling.

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